

JC685 U.S. PTO  
03/23/00



LAW OFFICES  
**SUGHRUE, MION, ZINN, MACPEAK & SEAS, PLLC**

**CALIFORNIA OFFICE**

1010 EL CAMINO REAL  
MENLO PARK, CA 94025  
TELEPHONE (650) 325-5800  
FACSIMILE (650) 325-6606

**BOX: PATENT APPLICATION**

Assistant Commissioner for Patents  
Washington, D.C. 20231

March 23, 2000

JC598 U.S. PTO  
09/533678  
03/23/00

**JAPAN OFFICE**

TOEI NISHI SHIMBASHI BLDG. 4F  
13-5 NISHI SHIMBASHI 1-CHOME  
MINATO-KU, TOKYO 105, JAPAN  
TELEPHONE (03) 3503-3760  
FACSIMILE (03) 3503-3756

**Re:** Application of Masami HATORI  
**SEMICONDUCTOR LASER MODULE AND METHOD FOR FORMING SEMICONDUCTOR LASER  
MODULE**  
Our Reference: Q56799

Dear Sir:

Attached hereto is the application identified above including the specification, claims and twelve (12) sheets of drawings. The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total Claims	15 - 20 =	0 x \$18 =	\$ 000.00
Independent Claims	2 - 3 =	0 x \$78 =	\$ 000.00
Base Filing Fee	(\$690.00)		\$ 690.00
Multiple Dep. Claim Fee	(\$260.00)		\$ 000.00
<b>TOTAL FILING FEE</b>			<b>\$ 690.00</b>

Priority is claimed from:

Japanese Patent Application

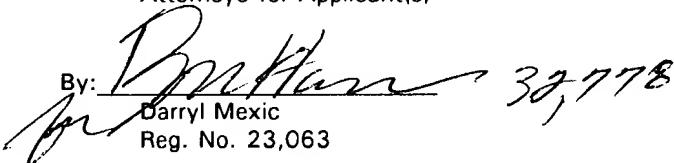
Filing Date

11-93845

March 31, 1999

The priority document will be submitted at a later date.

Respectfully submitted,  
**SUGHRUE, MION, ZINN, MACPEAK & SEAS**  
Attorneys for Applicant(s)

By:   
Darryl Mexic  
Reg. No. 23,063

DM:amt